



2858
DOCKET NO: Mic.6287

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Igel et al.

GROUP: 2858

SERIAL NO: 09/868,538

EXAMINER: Walter Benson

FILING DATE: June 19, 2001

FOR: CAPACITIVE MAGNETIC FIELD SENSOR

Sir:

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INFORMATION DISCLOSURE STATEMENT

In compliance with 37 C.F.R. §§1.56, 1.97, and 1.98, Applicant submits copies of the documents listed on the attached Form PTO-1449.

The Commissioner is authorized to charge Deposit Order Account No. 19-0079 for any further fee that is required.

Respectfully submitted,

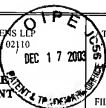
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I hereby certify that this correspondence (along with any paper referred to as being attached or enclosed) is being deposited on December 15, 2003 with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Tanya Bellanti

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**



ATTORNEY DOCKET NO. 6287

APPLICANT: Igel et al.

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U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A						
	B						
	C						
	D						
	E						
	E						
	G						
	H						

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FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
	I	DE69005685	1/5/94	Germany			YES-abstract
	J						
	K						
	L						
	M						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER INITIAL		
	N	Ayala et al., "A micromachined silicon magnetometer", Sensors and Actuators A 61, 339-341, 1991.
	O	

EXAMINER

DATE CONSIDERED

EXAMINER:

Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.